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7/31/02

PATENT
8733.039.20

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Jae Beom CHOI et al.

Group Art Unit: 2872

Application No.: 09/618,165

Examiner: Craig CURTIS

Filed: July 17, 2000

For: **LARGE SCALE POLARIZER AND POLARIZER SYSTEM
EMPLOYING IT**

RECEIVED
JUL 29 2002
TECHNOLOGY CENTER 2800

REPLY UNDER 37 C.F.R. §1.111

Commissioner of Patents
Washington, D.C. 20231

Dear Sir:

In response to an Office Action dated April 24, 2002, the following remarks are respectfully submitted.

IN THE CLAIMS:

Please AMEND claim 11 (a marked up version of the amended claims is attached).

11 (AMENDED). A polarizer system, comprising:

a light source for generating a light;

a quartz substrate part comprising a plurality of quartz substrates stacked on

top of one another;

a polarizer holder supporting the quartz substrate part; and

means for directing said light onto said quartz substrate part.

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